User Fees | OCCAM Electron Microscopy Facility

(New fee structure effective from September 01, 2016)

Please Note: All users are liable for the cost of any damage resulting from misuse, and/or abuse of equipment.

<table>
<thead>
<tr>
<th>Equipment</th>
<th>Rates</th>
<th></th>
<th></th>
</tr>
</thead>
<tbody>
<tr>
<td><strong>TM-3000 Table top SEM</strong></td>
<td><strong>Beam time per hour</strong></td>
<td><strong>Technologist Time per hour</strong></td>
<td></td>
</tr>
<tr>
<td>U of T and Other Universities</td>
<td>$30</td>
<td>$45</td>
<td></td>
</tr>
<tr>
<td>Industry</td>
<td>$80</td>
<td>$100</td>
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Contact: Sal Boccia | Email: s.boccia@utoronto.ca

<table>
<thead>
<tr>
<th><strong>SU-3500 VP SEM</strong></th>
<th><strong>Rates</strong></th>
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<tbody>
<tr>
<td>U of T and Other Universities</td>
<td>$45</td>
<td>$45</td>
<td></td>
</tr>
<tr>
<td>Industry</td>
<td>$80</td>
<td>$100</td>
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</table>

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<table>
<thead>
<tr>
<th><strong>SU-5000 Analytical FeSEM</strong></th>
<th><strong>Rates</strong></th>
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<tr>
<td>U of T and Other Universities</td>
<td>$50</td>
<td>$45</td>
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<tr>
<td>Industry</td>
<td>$150</td>
<td>$100</td>
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<table>
<thead>
<tr>
<th><strong>HF 3300 ETEM</strong></th>
<th><strong>Rates</strong></th>
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<td>U of T and Other Universities</td>
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<td>Industry</td>
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</table>

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### NB 5000 Dual Beam FIB

<table>
<thead>
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<tbody>
<tr>
<td></td>
<td>Beam Time per hour</td>
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<tr>
<td>U of T and Other Universities</td>
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<td>Industry</td>
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### IM 4000 Table Top Ion Mill

<table>
<thead>
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<tbody>
<tr>
<td></td>
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<tr>
<td>Industry</td>
<td>$75</td>
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### Misc. Sample Preparation

<table>
<thead>
<tr>
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<th>Rates per Coating Cycle</th>
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<tbody>
<tr>
<td>Gold Coating</td>
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</tr>
<tr>
<td>Carbon Coating</td>
<td>$15</td>
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</tbody>
</table>

U of T and Other Universities | Industry |

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**Acronyms:**

- **SEM**: Scanning Electron Microscope
- **FeSEM**: Schottky Variable Pressure Field Emission Scanning Electron Microscope
- **ETEM**: Environmental Transmission Electron Microscope